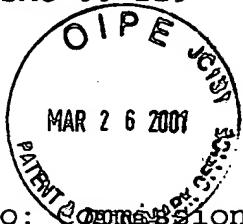


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March 22, 2001

To: Commissioner of Patents and Trademarks
Washington, D.C. 20231

Fr: George O. Saile, Reg. No. 19,572
20 McIntosh Drive
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Technology Center 2100
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Subject:	Serial No. 09/765,043 01/19/01
	Jia-Shun Yeh, Ren-Hua Tu
	PAYMENT MODEL FOR AN ENTERPRISE RESOURCE PLANNING SYSTEM
	Grp. Art Unit: 2164

INFORMATION DISCLOSURE STATEMENT

Enclosed is Form PTO-1449, Information Disclosure Citation
In An Application.

The following Patents and/or Publications are submitted to
comply with the duty of disclosure under CFR 1.97-1.99 and
37 CFR 1.56. Copies of each document is included herewith.

U.S. Patent 5,369,570 to Parad, "Method and System for
Continuous Integrated Resource Management", discusses a
resource management system.

U.S. Patent 6,088,626 to Lilly et al., "Method and
Apparatus for Scheduling Work Orders in a Manufacturing
Process", discusses a method for scheduling orders.

U.S. Patent 5,953,707 to Huang et al., "Decision Support System for the Management of an Agile Supply Chain", discusses a decision support system that works with the resource planning system and vendor management.

U.S. Patent 5,089,970 to Lee et al., "Integrated Manufacturing System", discusses an integrated manufacturing system.

U.S. Patent 5,787,283 to Chin et al., "Framework for Manufacturing Logistics Decision Support", discusses a manufacturing logistics decision support system.

U.S. Patent 6,005,571 to Pachauri, "Graphical User Interface for Managing Security in a Database System", teaches a graphical interface to a database.

Sincerely,


Stephen B. Ackerman,
Reg. No. 37761

**INFORMATION DISCLOSURE CITATION
IN AN APPLICATION**

(Use several sheets if necessary)

Doctoral Seminar (Topics)

Laguna Seca

TSMC-00229 09/765, 043

^{Accepted} Jia-Shun Yeh et al.

Filing Date / / Across All Units

01/19/01 | 2164

U. S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS (including Author, Title, Date, Portion or Pages, Etc.)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.